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Express Mail No. **EV 346 794 778 US**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Sebastien KERDILES et al.

Confirmation No. 8821

Application No.: 10/733,470

Group Art Unit: 2829

Filing Date: December 12, 2003

Examiner: J. Nguyen

For: **TOOLS AND METHODS FOR  
DISUNITING SEMICONDUCTOR  
WAFERS**

Atty. Docket No.: 4717-9100

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed November 2, 2005, applicants respectfully request entry of the following amendments and remarks into the file of this application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

A **Replacement Sheet** is submitted for drawing Figure 1.

No fee is believed to be due for this submission. Should any fees be required, please charge such fees to **Winston & Strawn LLP** Deposit Account No. 50-1814.